

#11/2/98
1-23-99
Cat
PATENT
8733D-6836

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:) Art Unit: NOT ASSIGNED
) Examiner: NOT ASSIGNED
CHOI, Duck-Kyun)
)
Serial No: NOT ASSIGNED)
)
Filed: October 13, 1998)
)
For: A METHOD FOR FABRICATING A THIN)
FILM TRANSISTOR)
_____)



TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT

Asst. Commissioner for Patents
Washington, D.C. 20213

Dear Sirs:

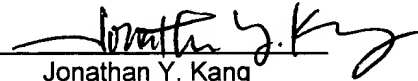
The information disclosure statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of a first Office Action on the merits, whichever event occurs last. 37 C.F.R. §1.97(b).

If it should be determined that for any reason either an insufficient or an excessive fee has been paid, please charge any insufficiency or credit any overpayment necessary to ensure consideration of the information disclosure statement for the above-identified application to Deposit Account No. 12-1820. A copy of this petition is enclosed.

Respectfully submitted,

LOEB & LOEB LLP

Date: October 13, 1998

By: 
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